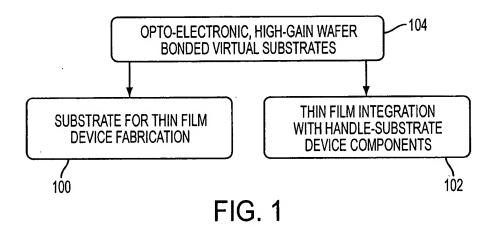


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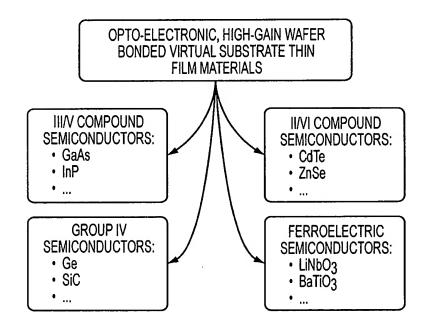


FIG. 2

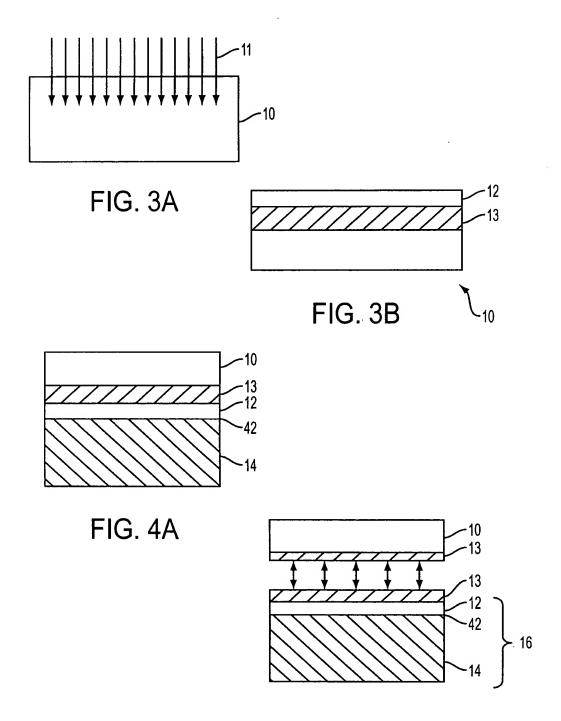


FIG. 4B

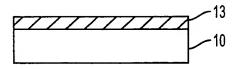


FIG. 5A

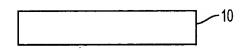


FIG. 5B

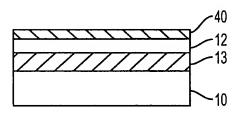


FIG. 6A

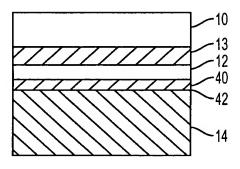


FIG. 6B

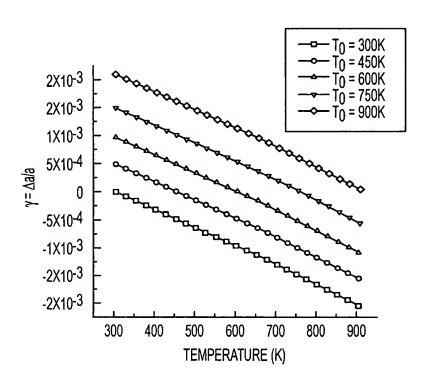


FIG. 7

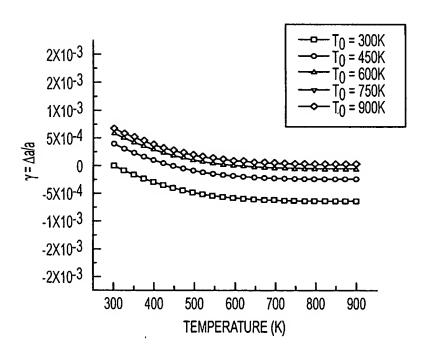
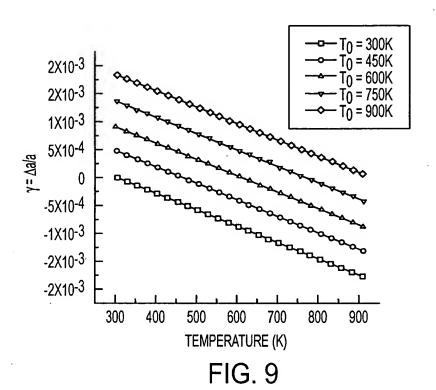
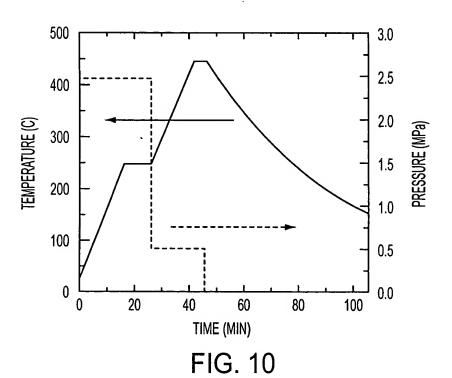


FIG. 8





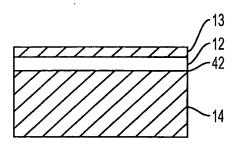


FIG. 11A

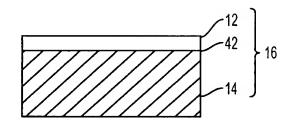


FIG. 11B

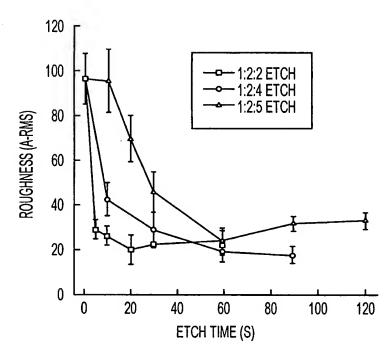
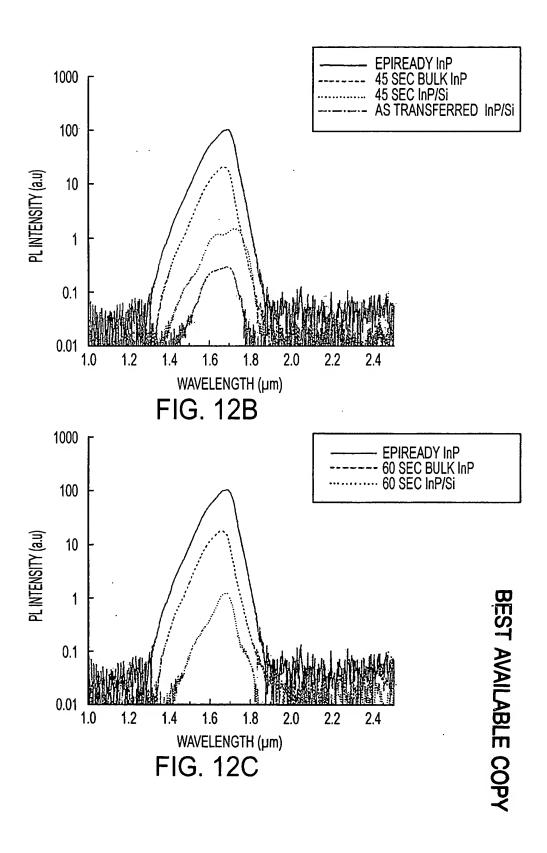
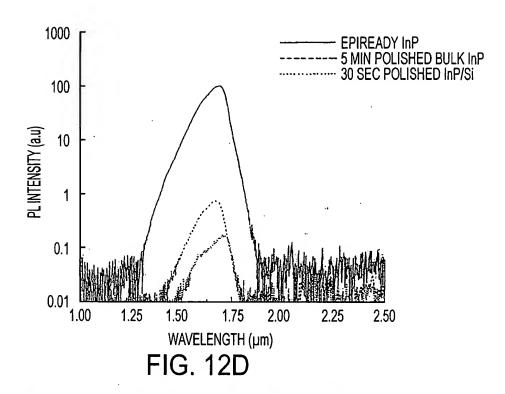


FIG. 12A



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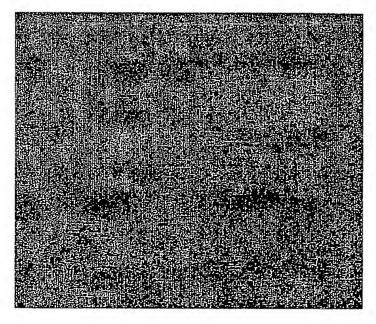
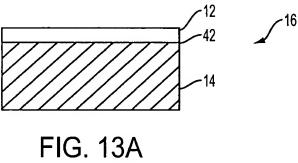


FIG. 12E

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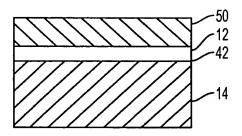


FIG. 13B

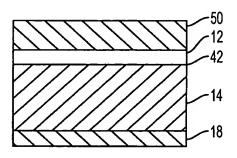


FIG. 14